

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Takashi WATANABE et al.**

Art Unit: **2818**

Application Number: **10/823,729**

Examiner: **David Vu**

Filed: **April 14, 2004**

Confirmation Number: **5344**

For: **SEMICONDUCTOR DEVICE FABRICATION METHOD**

Attorney Docket Number: **042341**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. §1.114

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

August 13, 2010

Sir:

This submission of Amendment under 37 CFR §1.114 is being filed concurrently with a Request for Continued Examination (RCE). The following amendments and remarks are respectfully submitted.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.